

Art Unit : 1742
Docket No. : 52433/766

IFW 1742

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Y. USHIGAMI et al.
Serial No. : 10/500,994
Filed : January 12, 2005
For : METHOD FOR MANUFACTURING GRAIN-ORIENTED SILICON
STEEL SHEETS WITH MIRROR-LIKE SURFACE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

☒ No additional fee is required.

The fee has been calculated as shown below.

				SMALL ENTITY		OTHER THAN A SMALL ENTITY	
CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	NO. PRESENT EXTRA	RATE	ADDIT. OR FEE	RATE	ADDIT. FEE	
TOTAL 15	MINUS 20	= 0	x6=	\$	x18 =	\$	0.00
INDEP. 5	MINUS 5	= 0	x18=	\$	x84 =	\$	0.00
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM			x60=	\$	x280=	\$	0.00
TOTAL				ADDIT. FEE	OR		
				\$			
					\$ 0.00		

☒ The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

☐ A petition for a ____ () month extension of time and Deposit Account authorization to cover the extension fee are enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 8, 2005.

John J. Kelly, Jr.
John J. Kelly, Jr. Reg. No. 29,182

Respectfully submitted,

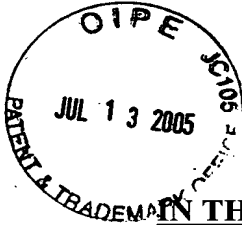
KENYON & KENYON

By: John J. Kelly, Jr.
John J. Kelly, Jr.
Reg. No. 29,182

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AMENDMENT

SIR:

Entry of the present amendment to the specification of the above-identified patent application is respectfully requested.